

# PATENT APPLICATION IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No: 299

29936/39868

PATENT APPLICATION TRANSMITTAL UNDER 37 C.F.R. 1.53

Comm P.O. B	issioner ox 1450	ent Application for Patents irginia 22313-1450				
Sir:						
Transm	nitted he	erewith for filing is the patent application of				
Inventors:		Seung Cheol Lee and Sang Wook Park				
Title:		METHOD OF FORMING TUNNEL OXIDE FILM IN SEMICONDUCTOR DEVICE				
1.	Type o	of Application				
	⊠	This is a new application for a  □ utility patent.  □ design patent.  This is a continuation-in-part application of prior application no.				
2.	Applic	Application Papers Enclosed				
	1 8 2 1 4	Title Page Pages of Specification (excluding Claims, Abstract, Drawings & Sequence Listing) Pages of Claims Page of Abstract Sheets of Drawings (Figs. 1A to 6)				

## **CERTIFICATION UNDER 37 CFR 1.10**

I hereby certify that this Patent Application Transmittal and the documents referred to as enclosed therewith are being deposited with the United States Postal Service on **December 8**, 2003, in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, utilizing the "Express Mail Post Office to Addressee" service of the United States Postal Service under Mailing Label No. **EV323761913US**.

Richard Zimmermann

3.	Decla	ration or Oath		
	X	Enclosed	Executed by (check all applicab  Inventors  Legal representative of i  (37 CFR 1.42 or 1.43)	•
			Joint inventor or person showin on behalf of inventor who refus reached	
			The petition required by 37 CFI required by 37 CFR 1.47 are enbelow for fee.	
			the undersigned attorney or age behalf of the applicant(s). An e	
4.	Small	<b>Entity Status</b>		
		Applicant clai	ms small entity status. See 37 C	FR 1.27.
5. Additional Papers Enclosed				
		Declaration of Computer read amino acid sed Microfiche co Associate Pow Verified trans An assignment	Pisclosure Statement If Biological Deposit dable copy of sequence listing concurred quence mputer program ver of Attorney lation of a non-English patent application Certification Under 35 U.S.C. 122	plication
6.	Priori	ity Application	s Under 35 USC 119	
		ified copy of the delow and is attace will fo		under 35 USC 119 is claimed
	CO	IINTRY	APPLICATION NO	FILED

COUNTRY	APPLICATION NO.	FILED
Republic of Korea	2003-42430	June 27, 2003

## Filing Fee Calculation (37 CFR 1.16) 7.

### **Utility Application** A. X

			SMALL ENTITY		OTHER THAN A SMALL ENTITY	
	NO. FILED	NO. EXTRA	RATE	FEE	RATE	FEE
BASIC FEE				\$385.00		\$770.00
TOTAL	5 - 20	= 0	X 9 =	\$	X 18 =	\$0.00
INDEP.	1 - 3	= 0	X 43 =	\$	X 86 =	\$0.00
: First Presenta	First Presentation of Multiple Dependent Claim + 145 =			\$	+ 290 =	\$0.00
Filing Fee:			iling Fee:	\$	OR	\$770.00
В.	Design Appl	ication		Filing Fee:	: \$	

	B. Design Application Filing Fee:		Filing Fee:	\$				
	C. P	lant Application	Filing Fee:	\$				
D.	Other Fees							
		or person on behalf of the inventor where inventor refused			<u>-</u>			
		to sign or cannot be reached Other		\$				
			Total Fees E	nclosed	<u>\$770.00</u>			
8.	Meti	Method of Payment of Fees						
,	X	Enclosed check in the amount of:			<u>\$770.00</u>			
		Charge Deposit Account No. 13-24 A copy of this Transmittal is enclo			\$			
		Not enclosed						

## 9. Deposit Account and Refund Authorization

The Commissioner is hereby authorized to charge any deficiency in the amount enclosed or any additional fees which may be required during the pendency of this application under 37 CFR 1.16 or 37 CFR 1.17 or under other applicable rules (except payment of issue fees), to Deposit Account No. 13-2855. A copy of this Transmittal is enclosed.

Please refund any overpayment to Marshall, Gerstein & Borun LLP at the address below.

## 10. Correspondence Address

Customer No.: 04743

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

6300 Sears Tower

233 South Wacker Drive

Chicago, Illinois 60606-6357

(312) 474-6300

(312) 474-0448 (Telefacsimile)

December 8, 2003

By: